



*§ 1.111*

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q77809

Shinichi OOIZUMI, et al.

Appln. No.: 10/689,039

Group Art Unit: 1732

Confirmation No.: 4510

Examiner: Matthew J. Daniels

Filed: October 21, 2003

For: PROCESS OF PRODUCING POROUS FILMS

**RESPONSE UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 2, 2005, please consider the remarks as submitted herewith on the accompanying pages. A petition for a three-month extension of time is submitted herewith, extending the due date for response to May 2, 2006.